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Mr. Byung Gwon Lee is a patent attorney at Shin & Kim. Mr. Lee's main areas of practice include patent application, trial, and litigation related to display, semiconductor, electrical, electronic, and telecommunications, and advisory on related intellectual property rights.

經歷

2022.12-Present Shin & Kim LLC
2022.7-2022.11 LG Display

學歷

2014-2022 Korea University, College of Engineering (B.E., Electrical Engineering)

資格

2022 Admitted to patent bar, Korea

言語

Korean, English

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